



Five Axes Stage Scanning Electron Microscope Lab With Tungsten Heated Electron Gun

Basic Information

Place of Origin: China
Brand Name: OPTO-EDU
Certification: CE, Rohs
Model Number: A63.7062
Minimum Order Quantity: 1 pc

Price: FOB \$1~1000, Depend on Order Quantity
 Packaging Details: Carton Packing, For Export Transportation

• Delivery Time: 5~20 Days

Payment Terms: T/T, West Union, Paypal

Supply Ability: 5000 pcs/ Month



Product Specification

Resolution: 4.5nm@30KV(SE); 6nm@30KV(BSE)

• Magnification: Negative Magnification: 15x~250000x;

Screen Magnification: 30x~500000x

• Electron Gun: Tungsten Heated Cathode-Pre Centered

Tungsten Filament Cartridge

Accelerating Voltage: 0~30KV

• Lens System: Three-level Electromagnetic Lens (Tapered

Lens)

• Specimen Stage: Five Axes Stage

• Highlight: five axes scanning electron microscope lab,

tungsten heated scanning electron microscope

lab



More Images





Product Description

- ♦Afforadable SEM
- ♦English Operation Panel
- ♦Full set of automated software
- ♦Modification Service Available
- ♦Bestseller SEM

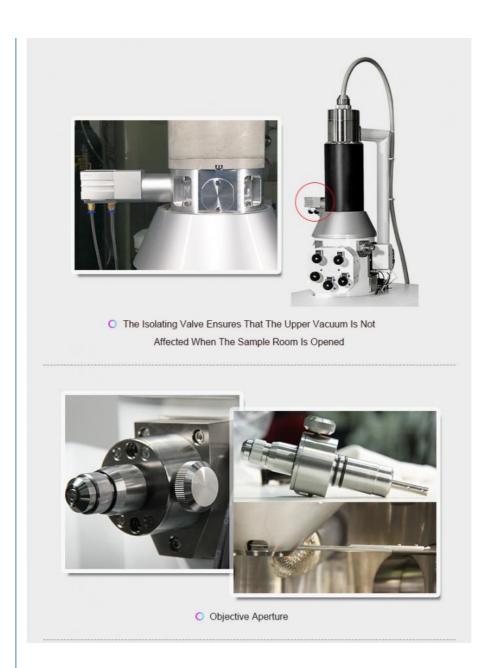
Scanning electron microscopy (sem) is suitable for the observation of the surface topography of metals, ceramics, semiconductors, minerals, biology, polymers, composites and nano-scale one-dimensional, two-dimensional and three-dimensional materials (secondary electron image, backscattered electron image). It can be used to analyze the point, line and surface components of microregion. It is widely used in petroleum, geology, mineral field, electronics, semiconductor field, medicine, biology field, chemical industry, polymer material field, criminal investigation of public security, agriculture, forestry and other fields.

A63.7062 Eco Tungsten Filament SEM						
Resolution		4.5nm@30KV(SE); 6nm@30KV(BSE)				
Magnification		Negative Magnification: 15x~250000x; Screen Magnification: 30x~500000x				
Electron Gun		Tungsten Heated Cathode-Pre Centered Tungsten Filament Cartridge				
Accelerating Voltage		0~30KV				
Lens System		Three-level Electromagnetic Lens (Tapered Lens)				
Objective Aperture		Molybdenum Aperture Adjustable Outside Vacuum System				
Specimen Stage		Five Axes Stage				
	X(Auto)	0~50mm				
Travel Range	Y(Auto)	0~50mm				
	Z(Manual)	0~25mm				
	R(Manual)	360º				
	T(Manual)	-5°~90°				
Max Specimen Diameter		150mm				
Detector		High Vacuum Secondary Electron Detector (With Detector Protection)				
Modification		Stage Upgrade;EBL;STM;AFM;Heating Stage;Cryo Stage;Tensile Stage;Micro-nano Manipulator;SEM+Coating Machine;SEM+Laser				
Accessories		CCD,LaB ₆ ,X-Ray Detector(EDS),EBSD,CL,WDS,Coating Machine				
Vacuum System		Turbo Molecular Pumps;Rotation Pump				
Electron Beam Current		10pAt~0.1μA				
PC		Customized Dell Work Station				

Tungsten Heated Cathode-Pre Centered Tungsten Filament Cartridge The Electromagnetic Lens In This Cylinder



The Isolating Valve Ensures That The Upper Vacuum Is Not Affected When The Sample Room Is Opened Objective Aperture



The Sample To Be Observed Need To Put IN The Sample Room Five Axes Stage, X/Y Motorized Control (Small)



O The Sample To Be Observed Need To Put IN The Sample Room



O Five Axes Stage, X/Y Motorized Control (Small)

Consu	ımables					
	Name	Specification	Quantity	Unit		
1	Centered cartridge filament		5	set		
2	Specimen cup	(φ13)	10	pcs		
3	Specimen cup	(φ32)	10	pcs		
4	Carbon conductive tape(double side)	6mm	1	рс		
5	Vacuum grease		1	Bottle		
6	Lint-free cloth		20	pcs		
7	Vent-pipe		5	meter		
8	Polishing paste		1	set		
Tools						
	Name	Quantity		Unit		
1	Allen wrench	1		set		
2	Clean stick	1		рс		
3	Overshot	1		рс		
4	Aperture removing tool	1		рс		
5	Tweezers	1		рс		
6	Screwdriver	2		pcs		

High Vacuum Secondary Electron Detector Optional Accessory Connection Interface



 $A63.7062\ Support\ Three\ Window\ Synchronous,\ Two\ Chanel\ (SE+BSE)\ With\ CCD\ Window;\ Image\ Resolution:\ 4096*4096$ Pixels











